

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2856**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Minoru KATAYAMA et al.

Group Art Unit: 2856

Application No.: 09/690,590

Examiner: M. Cygan

Filed: October 18, 2000

Docket No.: 107612

For: SURFACE TEXTURE MEASURING MACHINE, LEVELING DEVICE FOR  
SURFACE TEXTURE MEASURING MACHINE AND ORIENTATION-ADJUSTING  
METHOD OF WORKPIECE OF SURFACE TEXTURE MEASURING MACHINE

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 10, 2003 Office Action, please consider the following:

**Amendments to the Claims; and**

**Remarks.**

RECEIVED  
JUN -9 2003  
TECHNOLOGY CENTER 2800

DO  
NOT  
ENTER  
MTC  
06/16/03

#24/Amend F  
w/ Attach  
Amend  
6/10/03  
7/11/03  
OK